



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 16, 2026	
IGI Report Number	LG774635100
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	8.86 X 6.33 X 3.92 MM

GRADING RESULTS

Carat Weight	1.40 CARAT
Color Grade	G
Clarity Grade	VVS 2

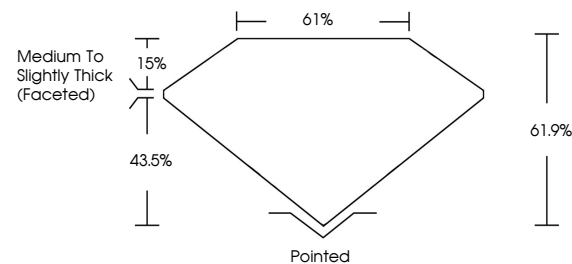
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	1631 LG774635100

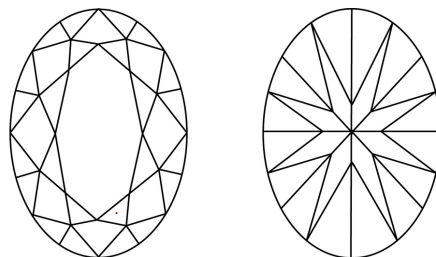
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG774635100
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

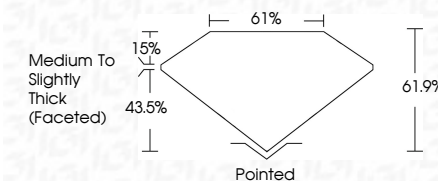
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www.igi.org

February 16, 2005	1.40 CARAT
GI Report No. LG774635100	G
IDEAL BRILLIANT	VVS 2
	61.9%
	Medium to Slightly Thick Faceted
	Polished
	EXCELLENT
	EXCELLENT
	NONE
	#69 LG774635100

Comments: This is a Very Fine, Crown Diamond was certified by Chemical Vapor Deposition (CVD) growth process.

Type IIA